

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/544,216
Applicant : Johan Klootwijk
Filed : August 1, 2005
TC/A.U. : 2811
Examiner : Sara W. Crane

Confirmation No. 9481

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DEC 07 2006

Docket No. : NL03 0089 US
Customer No. : 65913

Title : Trench Isolation Structure, Semiconductor Assembly Comprising
such a Trench Isolation, and Method for Forming such a Trench
Isolation

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE & AMENDMENT

Sir:

In response to the Non-Final Office action of October 4, 2006, please consider the
following:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 4 of this paper.

Amendments to the Drawings follow after the Remarks/Arguments in this
paper.

Remarks/Arguments begin on page 7 of this paper.

CERTIFICATE OF MAILING or TRANSMISSION	
I hereby certify that this correspondence is being:	
<input type="checkbox"/>	deposited with the United States Postal Service with sufficient postage for first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Arlington, VA 22313".
-OR-	
<input checked="" type="checkbox"/>	facsimile transmitted to the USPTO, on the date indicated below.
(Date) <u>07-DEC-2006</u>	(Signature) <u>Peter Zawilsk</u>
	(Name) <u>Peter Zawilsk</u>